



AF
D
FW

P/1250-254

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Akira IZUMI.

Date: July 19, 2005

Serial No.: 10/634,432

Group Art Unit: 3749

Filed: August 5, 2003

Examiner: Jiping LU

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE
PROCESSING METHOD DRYING SUBSTRATE BY SPRAYING GAS

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT/SUBMISSION

Sir:

This is a response to the Office Action mailed April 19, 2005 in the above-identified application. Reconsideration of the application is respectfully requested.

FEE CALCULATION

Any additional fee required has been calculated as follows:

_____ If checked, "Small Entity" status is claimed.

	NO. CLAIMS AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR		EXTRA PRESENT		RATE	ADDIT. FEE
TOTAL	11	MINUS	20	* =	0	X	(\$25 SE or \$50)	\$0
INDEP.	4	MINUS	4	** =	0	X	(\$100 SE or \$200)	\$0
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM						X	(\$180 SE or \$360)	\$0

* not less than 20 ** not less than 3

TOTAL \$ 0

If any additional payment is required, a check which includes the calculated fee of \$ _____
(OFGS Check No. _____) is attached.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

*Do not
enter
J.L
8/18/05*